

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

SERIAL NO.: 10/055,320

ART UNIT: 2812

APPLICANT: Bassom and Mai

EXAMINER: Not assigned

FILING DATE: 01/23/2002

TITLE: Fabrication of High Resistivity Structures Using Focused Ion Beams

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Prior to examination, please amend the application as follows:

In the specifications:

On page 1, after the title and before "Technical Field of the Invention", insert the following paragraph:

Q1 -- This application claims priority from U.S. Provisional Patent Application No: 60/264,472, filed January 26, 2001.--

Remarks

Applicants insert into the specifications an indication of the priory which was claimed in the declaration.

Respectfully submitted,

Date: 3/21/02

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CERTIFICATE OF MAILING

I hereby certify that this paper or fee is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231, on the 21th day of March, 2002

By: Kathleen Scheinberg
Name: Kathleen Scheinberg